

ABSTRACT OF THE DISCLOSURE

The present invention is directed to firmly fix a lid unit to a container body, facilitate cleaning and drying of components, and suppress rotation of semiconductor wafers caused by shake. The invention provides a lid unit for a manufacturing line for closing a container body of a thin plate supporting container. A simple attaching/detaching mechanism is provided with: a locking member which is projected and retained by the container body side; a feeding member which is connected to the locking member to make the locking member project/retract; a tip-side cam for pressing a tip side of the locking member to one side when the locking member is projected by the feeding member; a base-end lower cam for pressing a base-end side of the locking member to the other side; and a base-end upper cam and a cam pressing projection for pressing the base-end side to the other side in a manner similar to the base-end lower cam. The simple attaching/detaching mechanism is detachably attached and can be disassembled into components. Supporting ribs for supporting a connecting and supporting plate and a supporting projection bar formed so that its ends are thin and its center portion is thick are also provided.